# Analysis chain in Japan

In NEWS meeting @Napoli 27-28/Oct./2016

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# topic

• Analysis chain

Scan -> Ellipse fit -> Dust removal

• Scanning results about LNGS sample

### Flow of analysis by Ellipse fitting PTS\_Scanning

Katsuragawa's NEWS meeting slide in 28/11/2014 • Stop & Go •.bmp (8bit\_1ch \*4Mpixel = 4Mbyte/1picture)

#### Ellipse fitting

- •High pass filter •Binarization •Labeling (clustering of pixels)
- Contour retrieval 
  Ellipse fit

#### **Best focus selection**

- •Event sort (brightness) •Clustering (use distance)
- Best focus selection(use brightness)



#### Noise rejection

Surface & bottom cut Dust rejection x2

linor Ellipse fit



#### Dust(Noise) rejection in 1<sup>st</sup> scan

Raw data (without any cuts) of 1<sup>st</sup> scanning has many multiple-hits induced by large or middle size dust (> 10 um). => its should be removed.



# Scanning about LNGS sample

Sample list scanned in Nagoya

- Batch ID of NIT; FAN079f (f = filtered)
  - □ Nagoya sample (before LNGS) x3

- Only fix

- MAA dev. + fix
- Filtered gelatin about FAN079f

(ID 65)

ID 41)

□ LNGS Sample x3 (+1)

- 0 week (ID 42)
- 1 week
- 0 week PMMA (ID 26)
- (- beta*,*

Talked by Asada (or Valerio)



### Raw data about "Sample\_42"



### To remove large type dust



# Summary of FAN079f



#### Raw data of "Sample\_41" (β-ray sample) \*\*w/o Ag coating



## points

- LNGS sample and Nagoya sample(same NIT) looks like same quality.
- PMMA(=acrylic base) has also same results.
- Beta sample has strong dependence of irradiation direction
  - => Surface recognition and fiducial volume cut are very important for comparison between Japan and Italy

\*\*especially, surface recognition for each view is essential.